



IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : **Mail Stop: ISSUE FEE**
Takahisa HAYASHI : **Confirmation No. 6435**
Serial No. 10/699,734 : [Group Art Unit 2826
Filed November 4, 2003 : Examiner Victor A. Mandala]

SEMICONDUCTOR
DEVICE AND METHOD OF
MANUFACTURING THE SAME

AMENDMENT UNDER 37 CFR 1.312 - AFTER
RECEIPT OF NOTICE OF ALLOWANCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEES FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975

Sir:

Kindly amend the above-identified application as follows.